

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-150003	Application No. 09/696,863
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Yamazaki, et al.	
		Filing Date October 25, 2000	Group Art Unit 2881

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
<i>415</i>	AA	6,160,262	12/12/2000	Aoki et al.			
	AB						
	AC						
	AD						
	AE						
	AF						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
<i>415</i>	AG	08-077961	03/22/1996	Japan			X	
	AH	63-157868	06/30/1988	Japan			ABS	
	AI	04-104441	04/03/1992	Japan			ABS	
	AJ	05-082083	04/02/1993	Japan			ABS	
	AK	05-128984	05/25/1993	Japan			ABS	
	AL	07-161337	06/23/1995	Japan			ABS	
	AM	64-001455	01/06/1989	Japan				X
<i>415</i>	AN	06-060099	08/19/1994	Japan				X

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
<i>415</i>	AO	M. Naito et al. "High Current Ion Implantation System for Research Use, PR-200A-RD", The Nissin Electric Review, Vol. 35, No. 2, 1990, pp. 25-31
<i>415</i>	AP	N. Nagai et al. "New Generation Parallel Beam Implanter EXCEED 2000", The Nissin Electric Review, Vol. 39, No. 3, 1994, pp. 9-18
	AQ	
	AR	

Examiner Signature <i>Michael Wells</i>	Date Considered <i>May 16, 2003</i>
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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	AK						

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							Yes	No
12/15	AL	04-160745	6/4/92	Japan			Abstract only	
12/15	AM	06-291073	10/18/94	Japan			Abstract only	
12/15	AN	07-007060	1/31/95	Japan			Concise Statement	
12/15	AO	09-298043	11/18/97	Japan			Abstract only	
	AP							

## Other Documents (include Author, Title, Date, and Place of Publication)

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	AR	
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Examiner Signature <i>Michael Pella</i>	Date Considered May 16, 2003
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